## APPLICATION DATA SHEET

Electronic Version 0.0.11

Stylesheet Version: 1.0

Attorney Docket Number: Atmi-497

Publication Filing Type:

new-utility

Application Type:

utility

Title of Invention:

BARRIER STRUCTURES FOR INTEGRATION OF HIGH K OXIDES

WITH Cu AND AI ELECTRODES

Attorney Docket Number:

Atmi-497

Suggested Representative Figure: Figure 1

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